



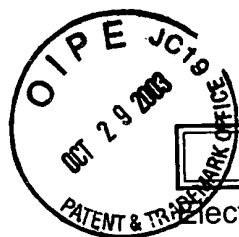
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Electronic Patent Application Submission  
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EFS ID: 49916  
Application ID: 09912844  
Title of Invention: HIGH PRESSURE PROCESSING  
CHAMBER FOR SEMICONDUCTOR  
SUBSTRATE  
First Named Inventor: Maximilian Biberger  
Domestic/Foreign Application: Domestic Application  
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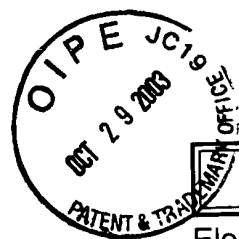
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<b>Title of Invention</b>	<b>HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE</b>																
<table><tr><td>Application Number:</td><td>09/912844</td><td></td></tr><tr><td>Date:</td><td colspan="2">2001-07-24</td></tr><tr><td>First Named Applicant:</td><td colspan="2">Maximilian A. Biberger</td></tr><tr><td>Confirmation Number:</td><td colspan="2">5915</td></tr><tr><td>Attorney Docket Number:</td><td colspan="2"></td></tr></table>			Application Number:	09/912844		Date:	2001-07-24		First Named Applicant:	Maximilian A. Biberger		Confirmation Number:	5915		Attorney Docket Number:		
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<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>SSI00501C-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	SSI00501C-usidst.xml		us-ids.dtd		us-ids.xsl							
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<b>Comments</b>																	



# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18  
Stylesheet Version v18.0

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	14	6082150	2000-07-04	Stucker	
	15	6085935	2000-07-11	Malchow et al.	
	16	6097015	2000-08-01	McCullough et al.	
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	18	6145519	2000-11-14	Konishi et al.	
	19	6159295	2000-12-12	Maskara et al.	
	20	6164297	2000-12-26	Kamikawa	
	21	6203582	2001-03-20	Berner et al.	B1
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	23	6239038	2001-05-29	Wen	B1
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	25	6251250	2001-06-26	Keigler	B1
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	28	6305677	2001-10-23	Lenz	B1
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	31	6388317	2002-05-14	Reese	B1
	32	6389677	2002-05-21	Lenz	B1
	33	6418956	2002-07-16	Bloom	B1
	34	6436824	2002-08-20	Chooi et al.	B1
	35	6454945	2002-09-24	Weigl et al.	B1
	36	6464790	2002-10-15	Shertinsky et al.	B1

## Remarks

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## Signature

Examiner Name	Date